

<b>Notice of References Cited</b>	Application/Control No. 10/082,318	Applicant(s)/Patent Under Reexamination IKEDA ET AL.	
	Examiner Donghee Kang	Art Unit 2811	Page 1 of 1

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	B	US-5,357,807 A ✓	10-1994	Guckel et al.	73/721
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	U	S>Wolf, "Silicon Processing for the VLSI Era, Vol.1, pp564.
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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a) )  
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